



INFORMATION CITED BY APPLICANT THAT MAY BE MATERIAL TO THE
PROSECUTION OF THE SUBJECT APPLICATION

Applicant: L. Chen Attorney Docket No. SEMT116013
Application No.: 09/045,245 Group Art Unit: 1741
Filed: March 20, 1998 Examiner: W.A. Nicholas
Title: APPARATUS AND METHOD FOR ELECTROLYTICALLY DEPOSITING
COPPER ON A SEMICONDUCTOR WORKPIECE (AS AMENDED)

U.S. PATENT DOCUMENTS

| *Examiner Initial | ID | Document No. | Date | Name |
|----------------------|----|-----------------|------------|-------------------------|
| U4. | U3 | 3,664,933 | 05/23/1972 | Clauss |
| | U4 | 4,000,046 | 12/28/1976 | Weaver |
| | U5 | 4,134,802 | 01/16/1979 | Herr |
| | U6 | 5,908,543 | 06/01/1999 | Matsunami <i>et al.</i> |
| U4. | U7 | 5,932,077 | 08/03/1999 | Reynolds |

FOREIGN PATENT DOCUMENTS

NONE.

OTHER INFORMATION

(Including Author, Title, Date, Pertinent Pages, Etc.)

NONE.

Examiner

U4. J. S. R.

Date Considered

1/03/01

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

MSK:mgp

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